



ACF bonding update and analysis of ACF interconnect yield from Timepix3 ACF test-beam data from DESY

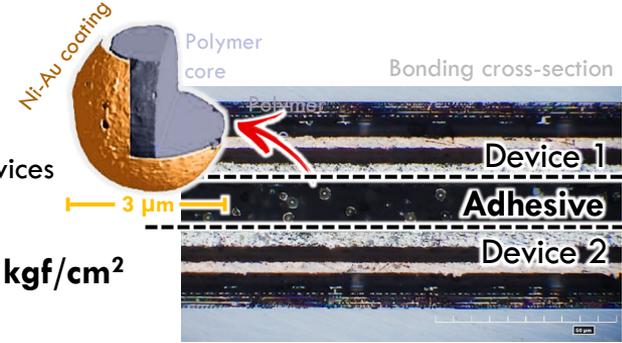
ACF in the industry

ACF is the **dominating interconnection** technology in the **display industry**

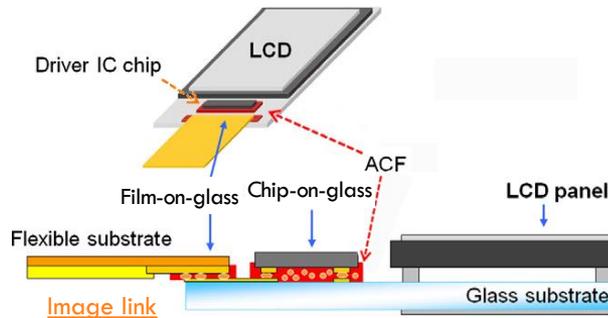
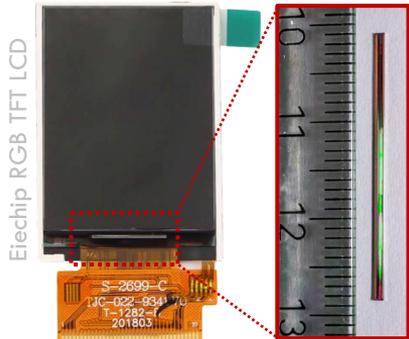
- **Adhesive film** embedded with **conductive micro-particles** (CP)
 - ▣ Particles are **compressed** (only vertically) and connect electrically the pads of the devices
 - **Mechanical attachment** is achieved with the thin adhesive layer

“Hybridization” ACF: 18 μm thick with 3 μm CPs: Bonding pressure of 300~800 kgf/cm²

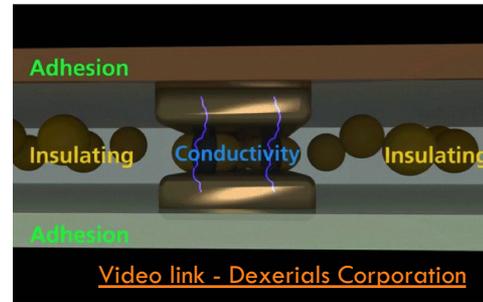
- ▣ Timepix3: 256x256 * 320 μm² ≈ 0.20 cm² → **61~163 kgf**



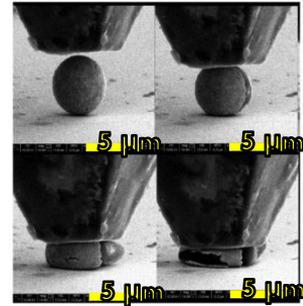
Display driver chip



ACF on contact pads



ACF particle deformation



In-house flip-chip hybridization

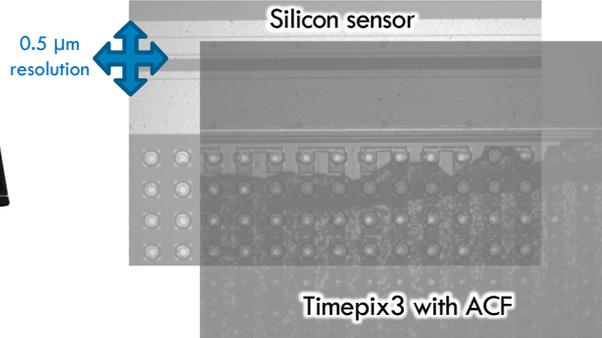
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- **Semi-automatic flip-chip bonder**, installed at Geneva University
 - ▣ Post-bonding accuracy **1-2 μm** achieved and planarity **< 100's μrad**
 - ▣ Heating up to **400°C** and force applied by bonding arm up to **100 kg**

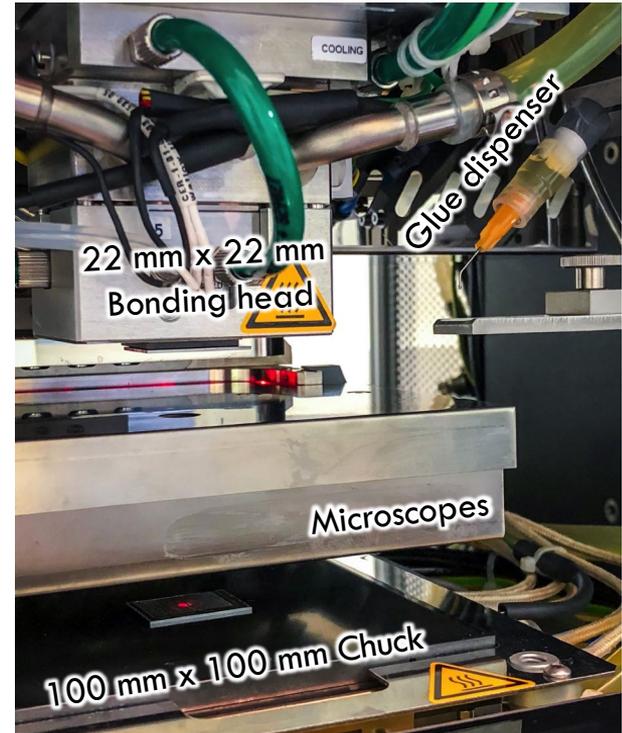
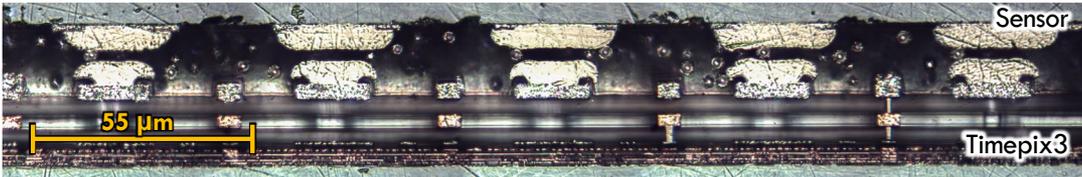


Flip-chip bonder



Bonding alignment

Timepix3-ACF-sensor assembly cross-section



Timepix3 hybridization with ACF

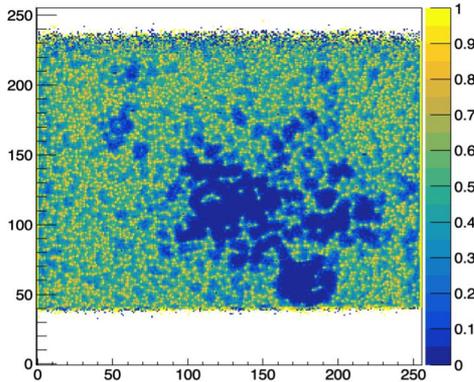
first tests – Bonding optimization

1. Timepix3 matrix **fully covered** with ACF → Low connectivity yield (<500 pixels)
2. sample covering ~**30%** of the matrix → **Uniform** and **high yield** connectivity)
3. sample with ~**50%** coverage → **Large area** with **good connectivity**, low yield in the central region

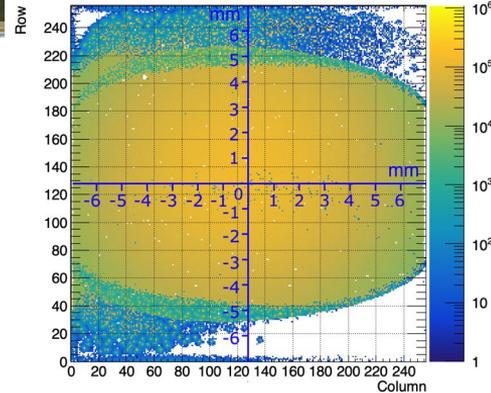
Proof-of-concept achieved: Successful pixel matrix bonding of **up to 1 cm²** (so far)

□ Optimization on going to reduce the necessary bonding force

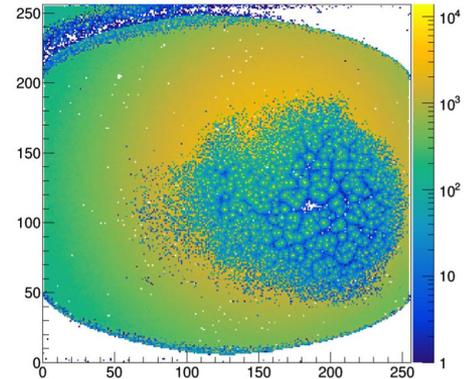
1. 100% ACF coverage
Test-beam efficiency



2. 30% ACF coverage
Sr-90 hit map



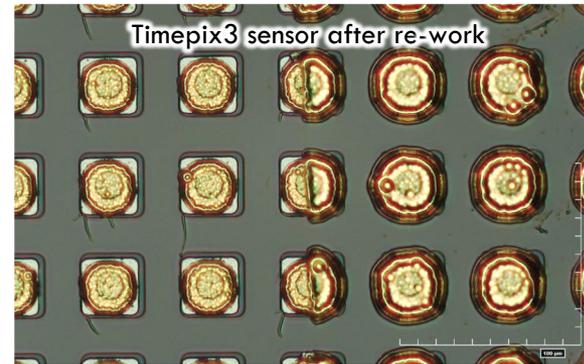
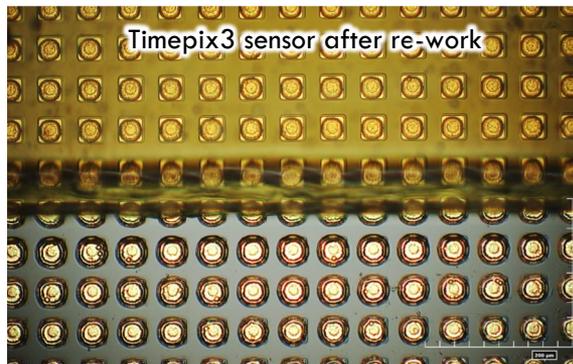
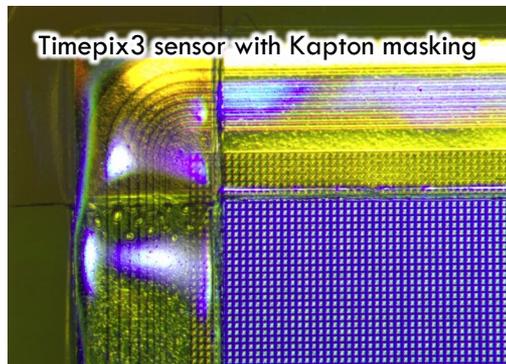
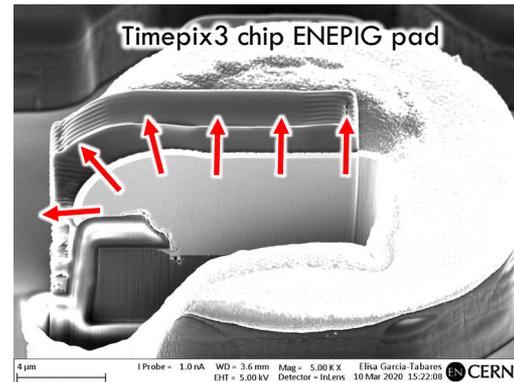
3. 50% ACF coverage
Sr-90 hit map



Timepix3 hybridization with ACF

Bonding/UBM optimization

- ENIG/ENEPIG can be re-worked (only increasing, not decreasing)
- **First idea:** To increase the size of the UBM pad in one of the devices
 - A **higher UBM pad** might decrease the volume of glue being squeezed out
 - One device keeps the UBM original size, making the bonding area to remain the same
- Two Timepix3 sensor devices (ENEPIG plated at PacTech) were reworked at CERN
 - **+5 μm Ni** added to the already existing Pd
 - One sample for mechanical cross-section and one for source measurement



Timepix3 hybridization with ACF

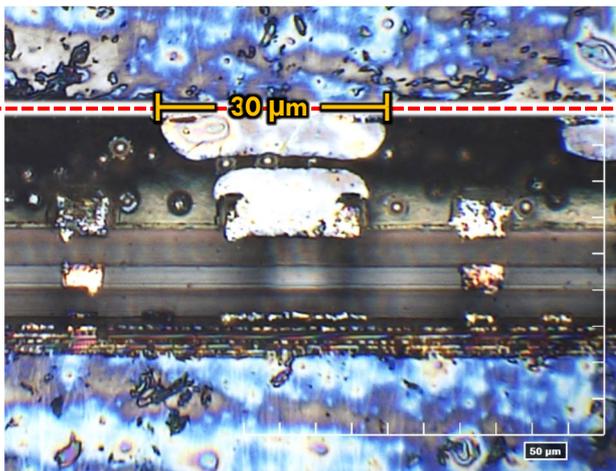
Bonding optimization – Resulting assemblies

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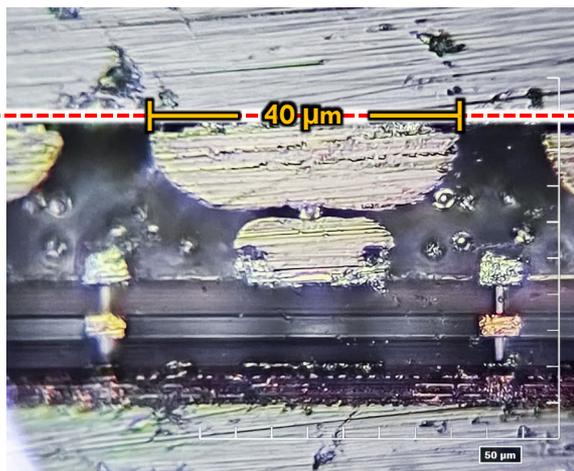
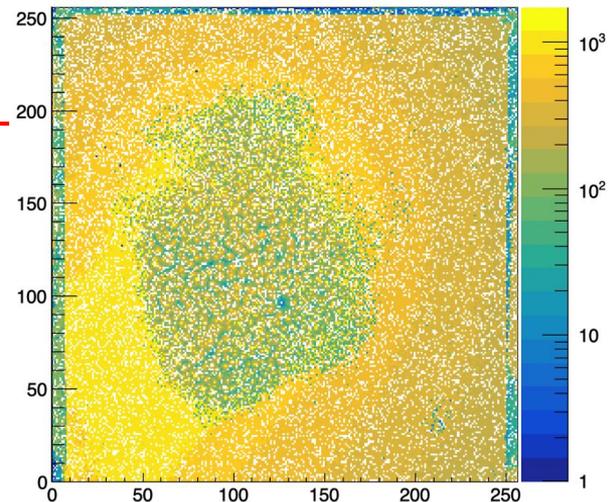
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- Cross-section indicates +5 μm of additional Ni
 - ▣ Pad isotropic growth: +10 μm in diameter and +5 μm in height
- Source measurement (sample with 100% ACF coverage) indicates possible bonding improvement

Timepix3 assembly with original ENEPIG



Timepix3 assembly with re-worked pad


 W43-E11 Sr^{90} source hit map


Test-beam at DESY

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Many thanks for the team at DESY!

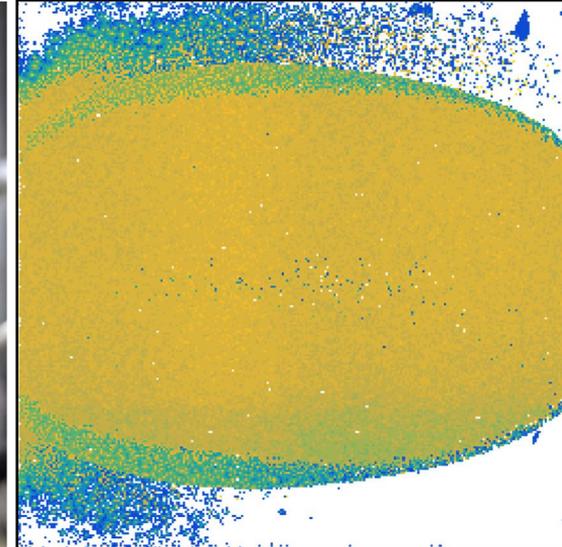
DESY telescope and W43-I3 sample



W43-I3 in the beam



W43-I3 Hitmap

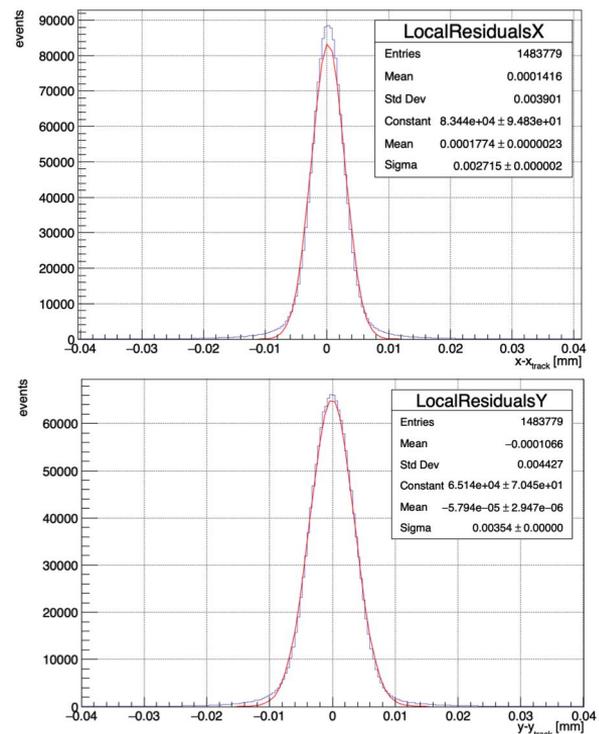
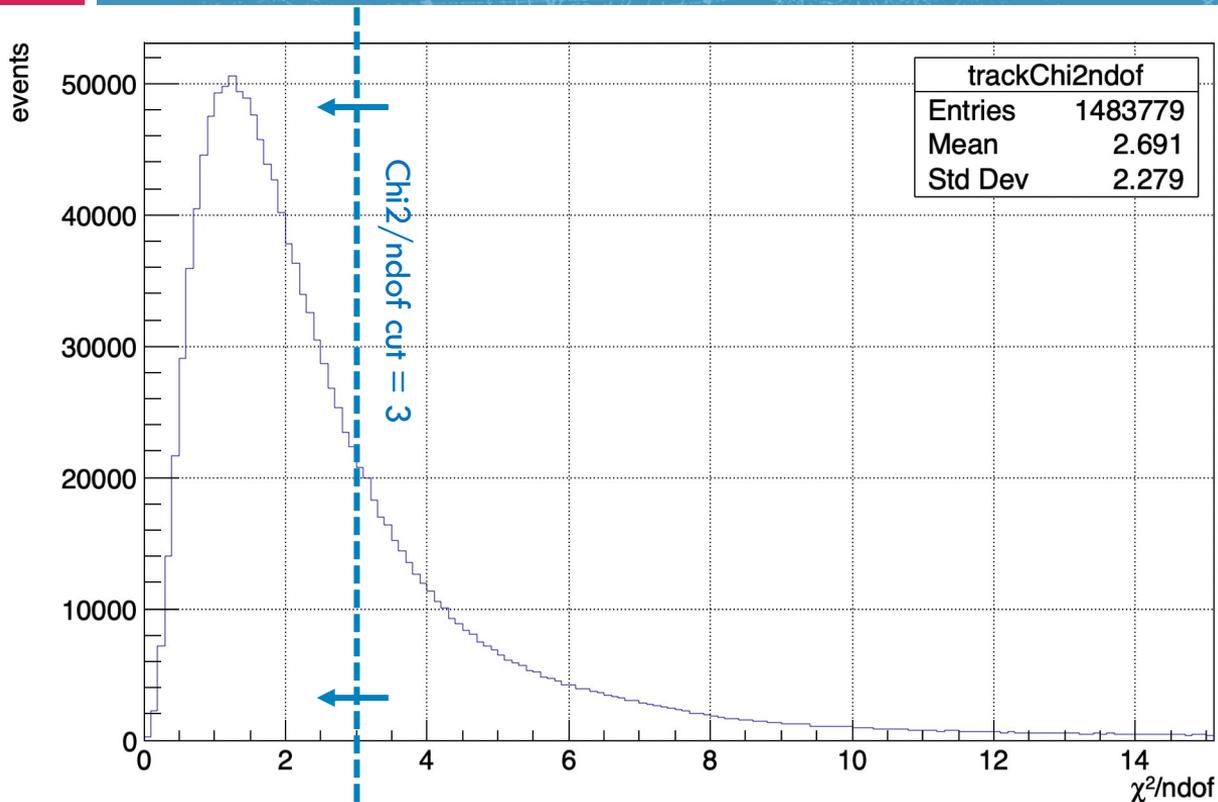


Track reconstruction

Tracks Chi2/ndof and 3rd plane residuals

7

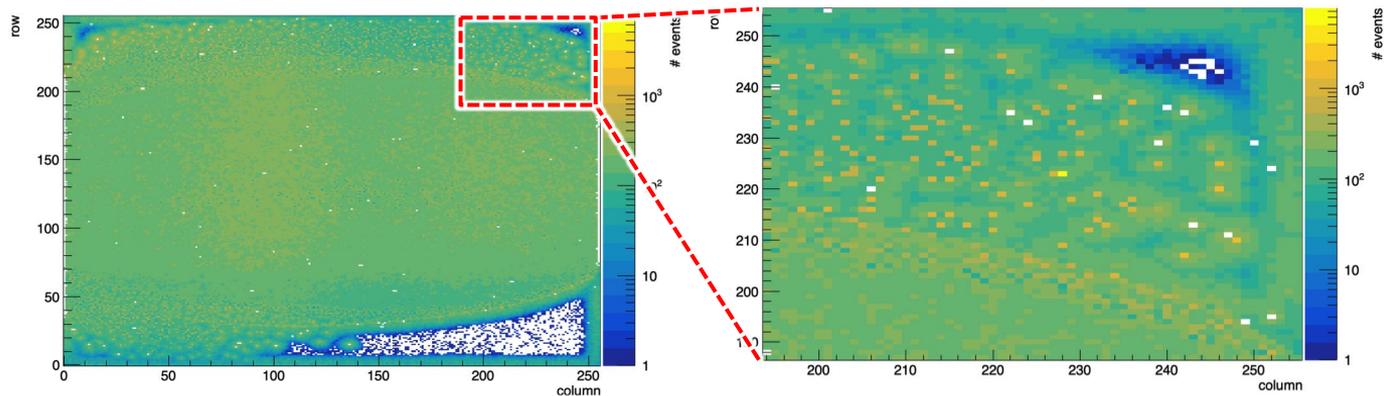
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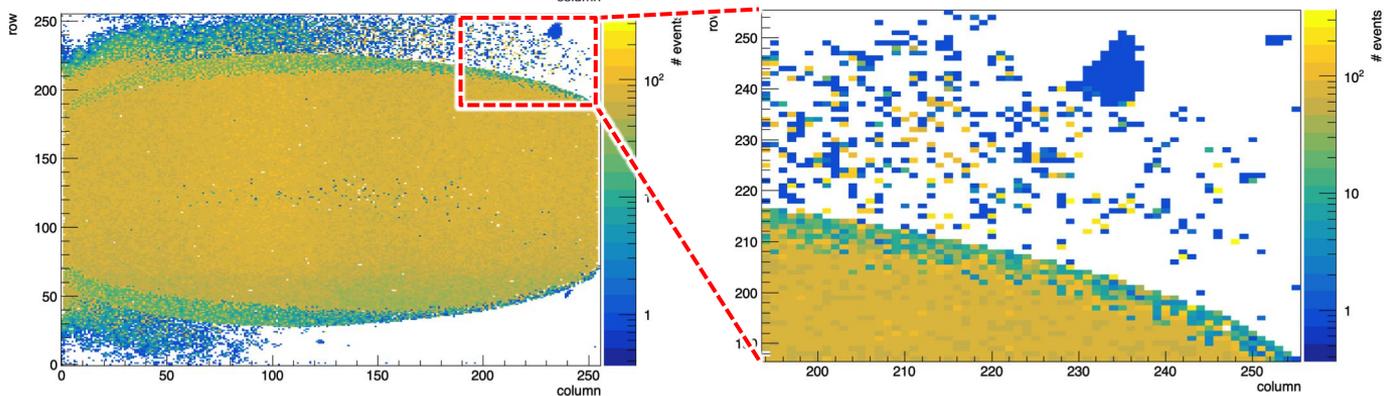
ACF Timepix3

W43-13 – Hit Map

Low threshold (run 6601)



High threshold (run 6614)

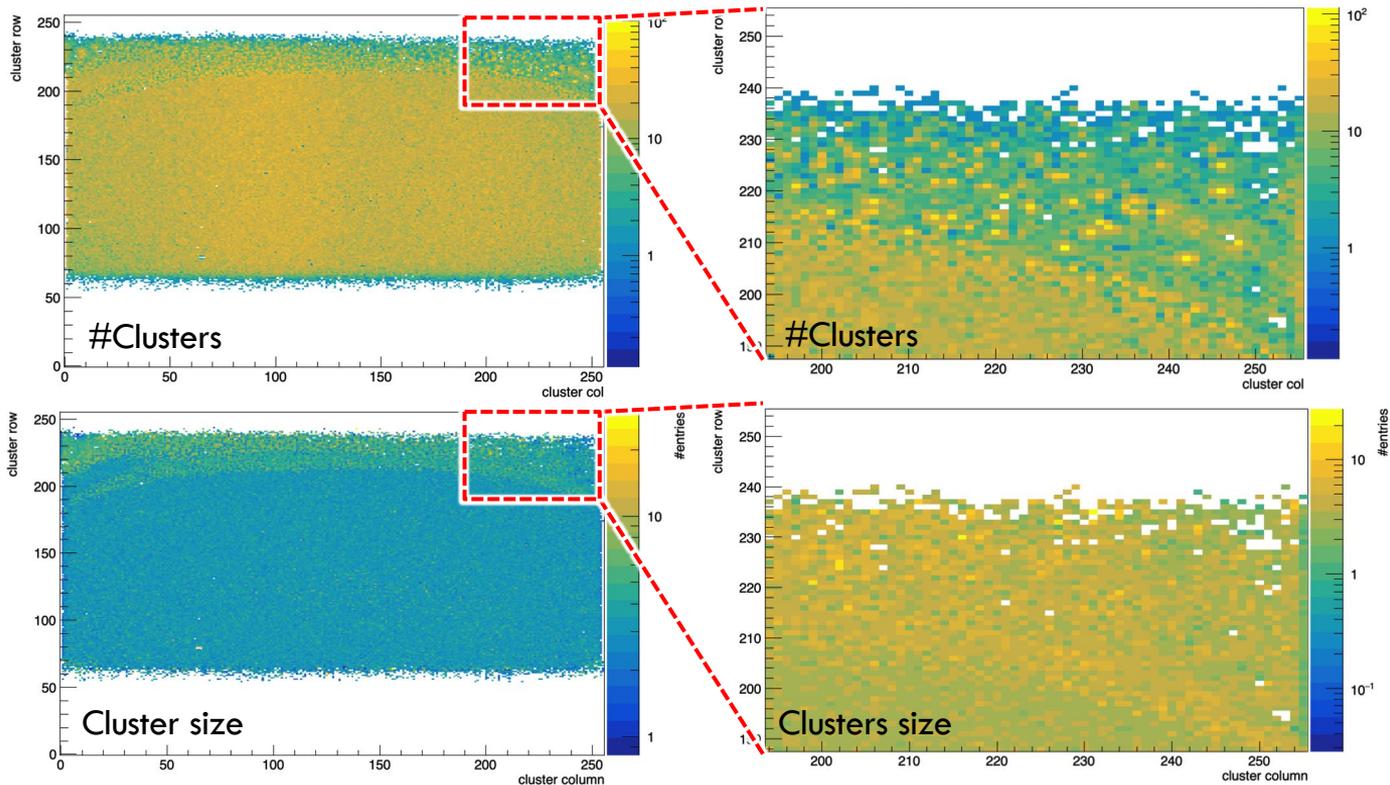


ACF Timepix3

W43-I3 – Associated Clusters



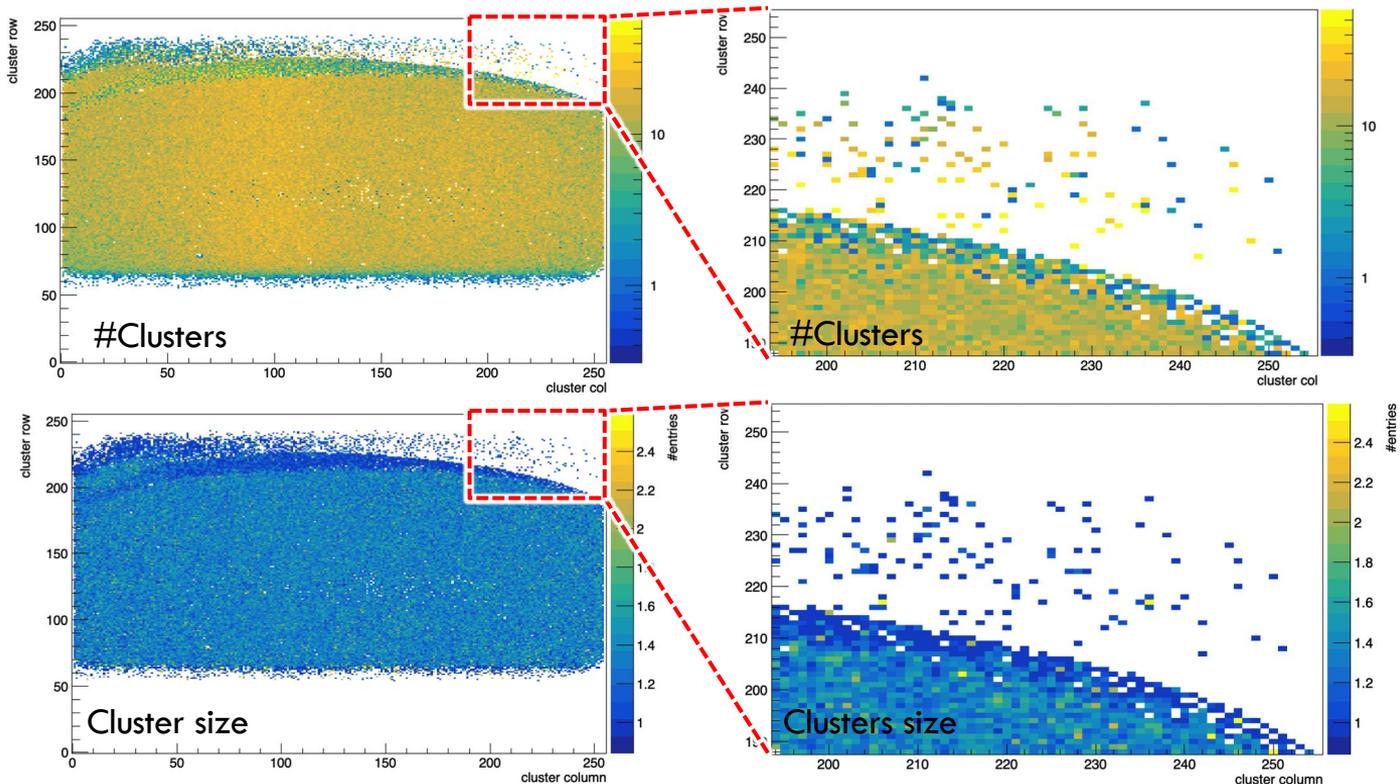
Low threshold (run 6601)



ACF Timepix3

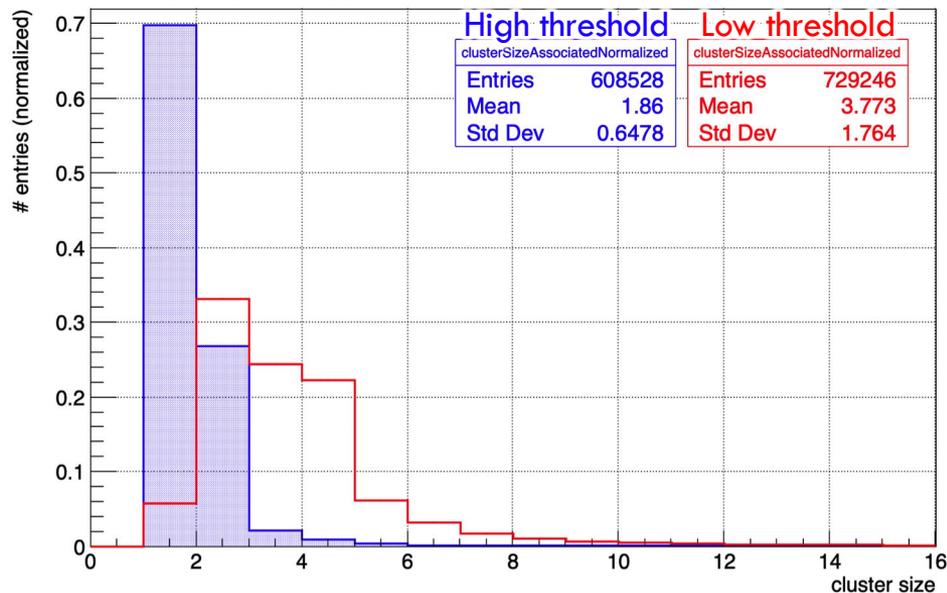
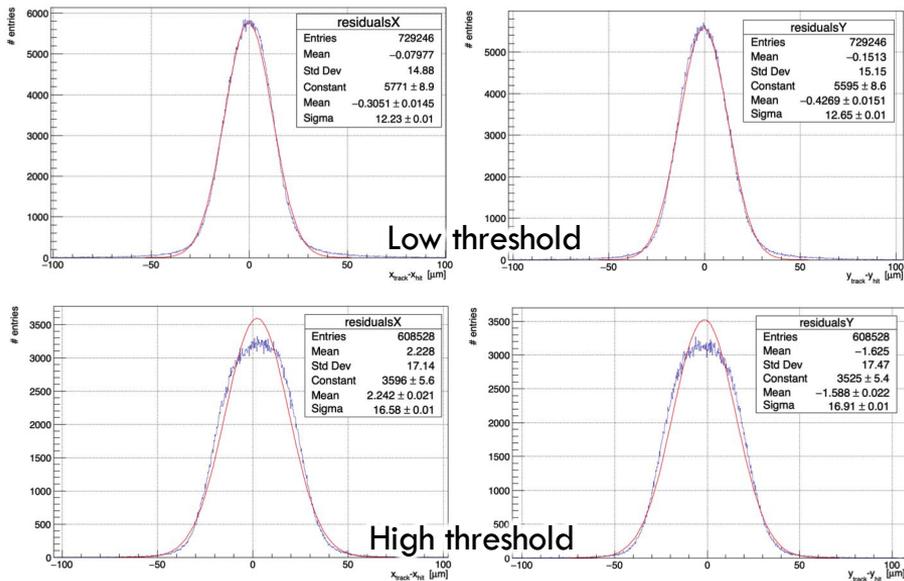
W43-I3 – Associated Clusters

High threshold (run 6614)



ACF Timepix3

W43-I3 – DUT residuals and cluster size



Efficiency profiles in corry

Simplified code



```
1 for(auto& track : tracks) {
2   bool has_associated_cluster = false;
3   auto globalIntercept = DUT->getIntercept(track.get());
4   auto localIntercept = DUT->globalToLocal(globalIntercept);
5
6   auto associated_clusters = track->getAssociatedClusters(DUT);
7   if(associated_clusters.size() > 0) {
8     auto cluster = track->getClosestCluster(DUT);
9     has_associated_cluster = true;
10    auto pixels = cluster->pixels();
11    for(auto& pixel : pixels) {
12      if(pixel->column() == static_cast<int>(DUT->getColumn(localIntercept)) &&
13        pixel->row() == static_cast<int>(DUT->getRow(localIntercept))) {
14        pixelEfficiency_TProfile->Fill(pixel->column(), pixel->row(), true);
15        if(track_within_inPixel_ROI) pixelEfficiencyROI_TProfile->Fill(pixel->column(), pixel->row(), true);
16      }
17    }
18  }
19
20  if(!has_associated_cluster){
21    pixelEfficiency_TProfile->Fill(DUT ->getColumn(localIntercept), DUT->getRow(localIntercept), false);
22    if(track_within_inPixel_ROI) pixelEfficiencyROI_TProfile->Fill(DUT ->getColumn(localIntercept), DUT ->getRow(localIntercept), false);
23  }
24
25  hChipEfficiencyMap_trackPos_TProfile->Fill(DUT->getColumn(localIntercept), DUT->getRow(localIntercept), has_associated_cluster);
26 }
```

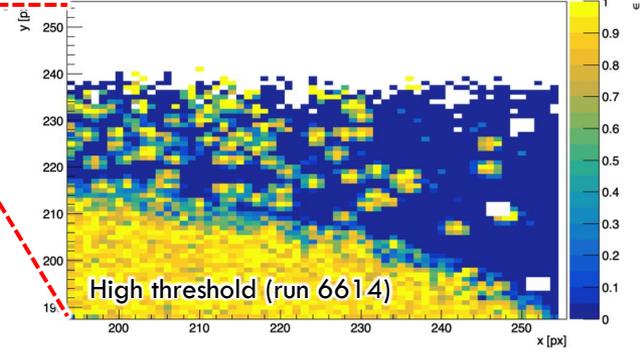
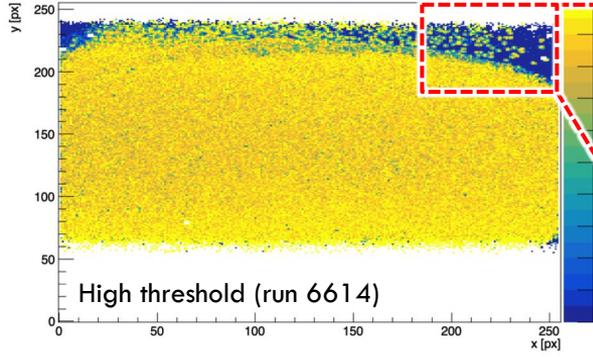
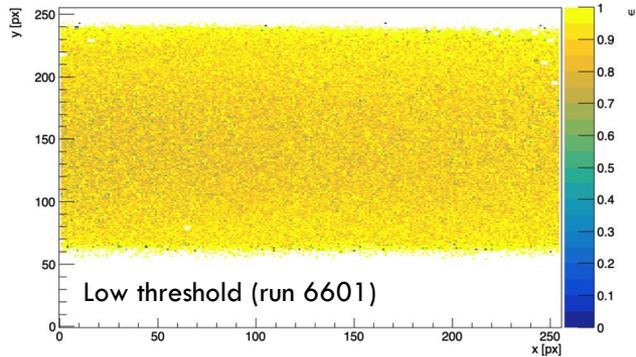
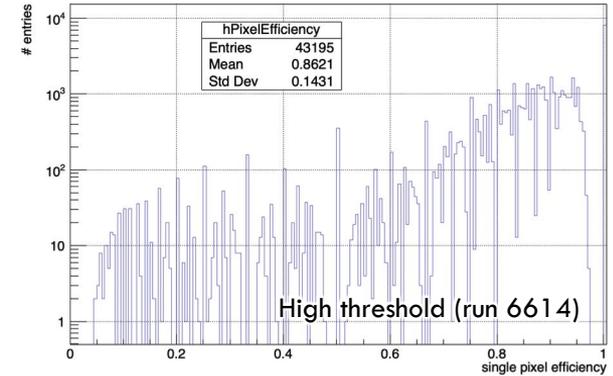
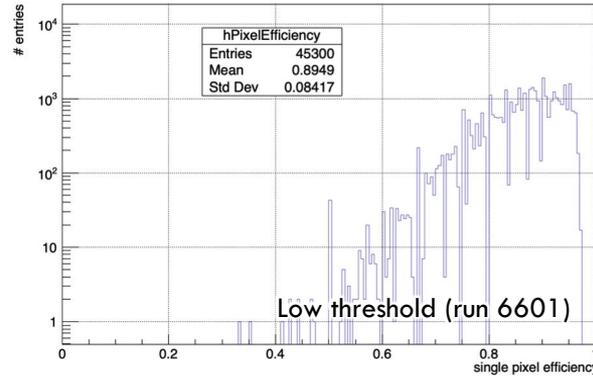
ACF Timepix3

W43-I3 – Chip Efficiency (track position)



hChipEfficiencyMap_trackPos_Tprofile

```
->Fill(DUT->getColumn(localIntercept),  
DUT->getRow(localIntercept),  
has_associated_cluster)
```



ACF Timepix3

W43-I3 – Chip Efficiency (associated pixel pos.)



```
if(cluster_pixel(x,y) == track_intercept(x,y))
```

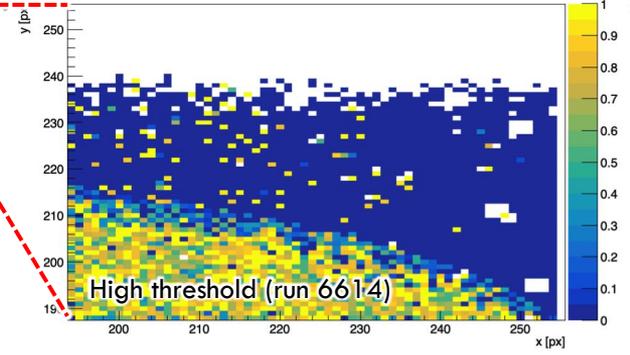
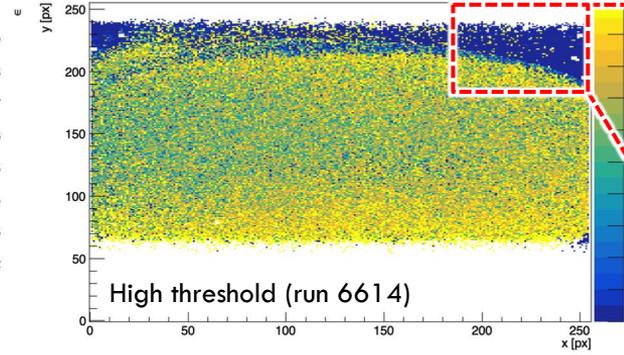
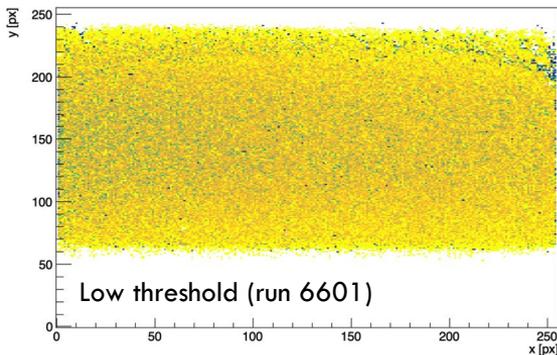
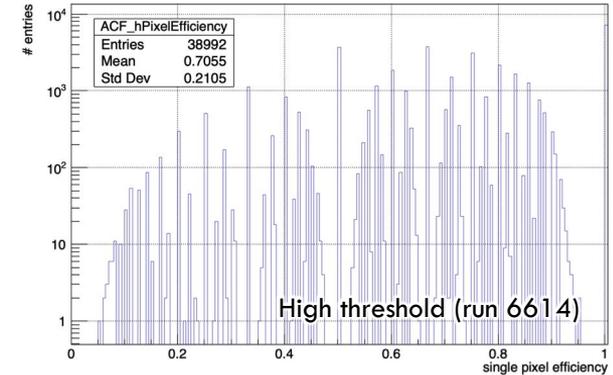
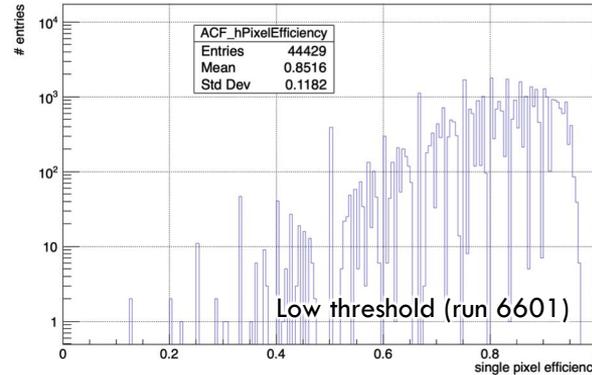
```
  pixelEfficiency Tprofile
```

```
  ->Fill(pixel->column(),  
         pixel->row(),  
         true);
```

```
if(!has_associated_cluster)
```

```
  pixelEfficiency Tprofile
```

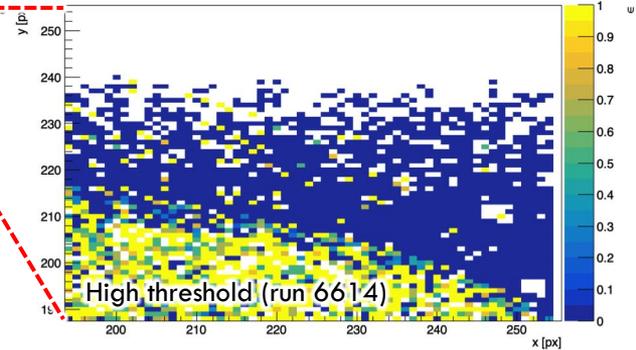
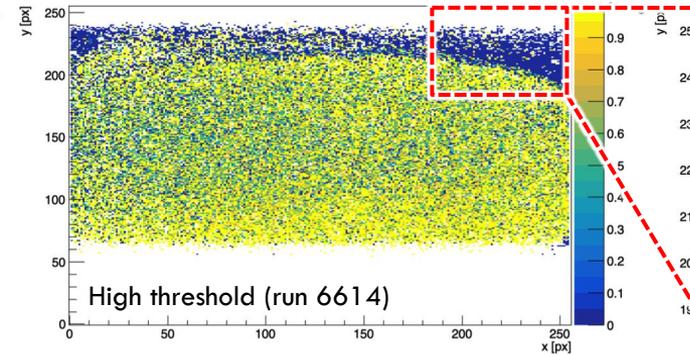
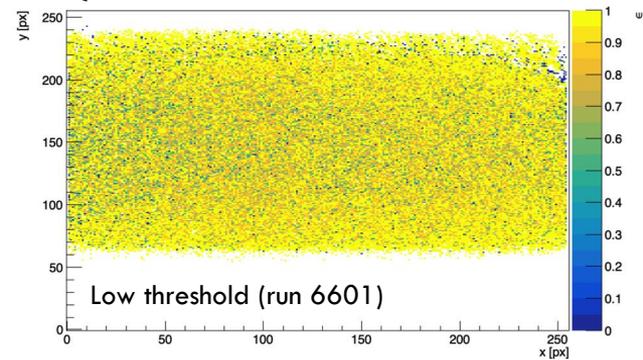
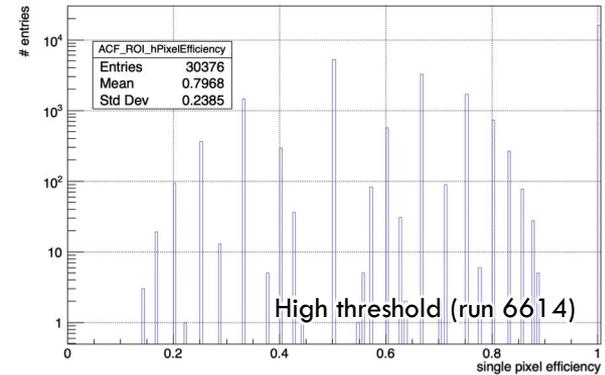
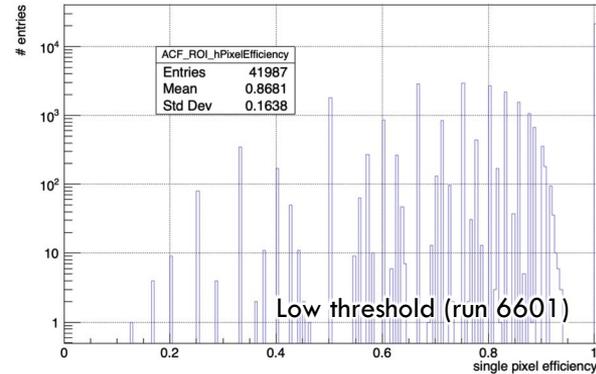
```
  ->Fill(DUT ->getColumn(localIntercept),  
         DUT->getRow(localIntercept),  
         false);
```



ACF Timepix3

W43-I3 – Chip Efficiency (associated pixel-ROI)

```
if(track_within_inPixel_ROI) {  
  if(cluster_pixel(x,y) == track_intercept(x,y))  
    pixelEfficiency ROI Tprofile  
    ->Fill(pixel->column(),  
           pixel->row(),  
           true);  
  if(!has_associated_cluster)  
    pixelEfficiency ROI Tprofile  
    ->Fill(DUT->getColumn(localIntercept),  
           DUT->getRow(localIntercept),  
           false);  
}
```



Summary and next steps

- Optimization of the device bonding topology might help to increase pixel hybridization yield
 - ▣ Re-work of UBM pad possible at CERN
 - Requires close follow-up for consistent plating and results
 - ▣ Estimated 5 μ m increase in the pad height
- New sample with 100% ACF coverage and with increased pad shows a bonding improvement
 - ▣ w.r.t. the first sample (also with 100% ACF coverage)
- Tested ACF Timepix3 assembly (with 30% ACF coverage) at DESY TB
 - ▣ Data analysis and interpretation still on-going
 - Next: Per-pixel efficiency curve (as function of threshold and bias-voltage)
 - Quantitative results limited by statistics available
- Two more samples to be tested at DESY TB when possible
 - ▣ Sample with 50% ACF coverage (#3 @ slide 7) and new sample with re-worked UBM pad
- CLICpix2 assemblies with new sensors from FBK and particle aligned ACF